



**RESPONSE UNDER 37 CFR § 1.116  
EXPEDITED PROCEDURE  
EXAMINING GROUP 1772**

**PATENT  
IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

**51048-2 DIV**

In re application of:  
Goela et al.

Serial No.: 09/870,242

: **MAIL STOP AF**

Filed: May 30, 2001

: Group Art Unit: 1772

For: METHOD AND APPARATUS FOR  
PRODUCING FREE-STANDING SILICON  
CARBIDE ARTICLES

: Examiner: Brian P. Egan

**ENTER**  
**BPE 11/16/04**

**REQUEST FOR RECONSIDERATION AFTER FINAL UNDER 37 CFR §1.116**

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Dear Sir:

In response to the Final Rejection mailed July 29, 2004, Applicants respectfully request reconsideration of the above-identified patent application.

Also enclosed with this response is an Information Disclosure Statement.